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APPLICANTS

Min Ho Jung, Ichon-shi, KOREA, REPUBLIC OF;
 Sung Eun Hong, Ichon-shi, KOREA, REPUBLIC OF;
 Jae Chang Jung, Ichon-shi, KOREA, REPUBLIC OF; Geun Su Lee, Ichon-shi, KOREA, REPUBLIC OF;
 Ki Ho Baik, Ichon-shi, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
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** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 2000-32984 06/15/2000 SJL

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: SJL	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 2	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
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ADDRESS
 04743
 MARSHALL, GERSTEIN & BORUN LLP
 233 S. WACKER DRIVE, SUITE 6300,
 SEARS TOWER
 CHICAGO, IL
 60606

TITLE
 Additive for photoresist composition for resist flow process

☐ All Fees